



Attorney's Docket No.: 042396-1-527

Patent

1765  
#3  
3/29/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Han-Ming Wu et al.

Examiner: Vinh, Lan

U.S. Serial No: 09/823,528

Art Unit: 1765

Filed: March 30, 2001

For: SHIELDING PLATE IN PLASMA FOR  
UNIFORMITY IMPROVEMENT

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231

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on March 21, 2003  
Date of Deposit  
Ieresa Edwards  
Name of Person Mailing Correspondence  
Ieresa Edwards 3/21/03  
Signature Date

RESPONSE TO ELECTION REQUIREMENT

Sir:

In response to the Election Requirement mailed March 13, 2003, applicant(s) hereby elects to prosecute Group I claims, claims 1-14 drawn to a chamber/an apparatus. As such, applicant(s) elects to withdraw Group II claims, claims 15-29 drawn to a method of generating ion fluz in a plasma-assisted material process conducted in a plasma chamber using a shielding plate.

If there are any additional charges, please charge Deposit Account No. 02-2666.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN

Date:

3/21/03

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